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10/797,661	03/10/2004	Kei Hiruma	9319G-000730	3945
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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

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1	Application No.	Applicant(s)
	10/797,661	HIRUMA, KEI
Office Action Summary	Examiner	Art Unit
••	Andrew Schechter	2871
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the d	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DATE - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period value Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be tire will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDONE	N. nely filed the mailing date of this communication. (D) (35 U.S.C. § 133).
Status		
1)⊠ Responsive to communication(s) filed on 03 De	ecember 2007.	
	action is non-final.	•
3) Since this application is in condition for allowar closed in accordance with the practice under E	·	
Disposition of Claims		
4) Claim(s) 16,17,20,22,27 and 28 is/are pending 4a) Of the above claim(s) is/are withdraw 5) Claim(s) is/are allowed.	wn from consideration.	
6)⊠ Claim(s) <u>16,17,20,22,27 and 28</u> is/are rejected		
7) Claim(s) is/are objected to.	r alaction requirement	
8) Claim(s) are subject to restriction and/or	r election requirement.	,
Application Papers		. 8
9) The specification is objected to by the Examine	r.	
10) The drawing(s) filed on 10 March 2004 is/are:	a)⊠ accepted or b)□ objected t	o by the Examiner.
Applicant may not request that any objection to the	drawing(s) be held in abeyance. Se	e 37 CFR 1.85(a).
Replacement drawing sheet(s) including the correct		
11)☐ The oath or declaration is objected to by the Ex	caminer. Note the attached Office	Action or form PTO-152.
Priority under 35 U.S.C. § 119		
12)⊠ Acknowledgment is made of a claim for foreign a)⊠ All b)□ Some * c)□ None of:	priority under 35 U.S.C. § 119(a	)-(d) or (f).
1.⊠ Certified copies of the priority documents	s have been received	•
2. Certified copies of the priority documents		ion No
3. Copies of the certified copies of the prior		
application from the International Bureau		<i>;</i>
* See the attached detailed Office action for a list	of the certified copies not receive	ed.
	•	
	•	•
Attachment(s)	•	
1) Notice of References Cited (PTO-892)	. 4) Interview Summary	(PTO-413)
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08)	Paper No(s)/Mail Do 5) Notice of Informal F	ate
<ol> <li>Information Disclosure Statement(s) (PTO/SB/08)</li> <li>Paper No(s)/Mail Date <u>12/3/07</u>.</li> </ol>	6) Other:	асент АррисацоП

10/797,661 Art Unit: 2871

#### **DETAILED ACTION**

## Request for Continued Examination

1. A request for continued examination under 37 CFR 1.114, including the fee set forth in 37 CFR 1.17(e), was filed in this application after final rejection. Since this application is eligible for continued examination under 37 CFR 1.114, and the fee set forth in 37 CFR 1.17(e) has been timely paid, the finality of the previous Office action has been withdrawn pursuant to 37 CFR 1.114. Applicant's submission filed on 26 September 2007 has been entered.

## Response to Arguments

2. Applicant's arguments filed 26 September 2007 have been fully considered but they are not persuasive. Applicant's arguments have been considered but are most in view of the new ground(s) of rejection.

The applicant has amended independent claims 16 and 20 to remove the word "thereby", which the examiner had previously indicated [p. 2 of the office action of 13 July 2007] required the method of claim 16 to have the diameter determined by the act of discharging the droplets such that they have the said weight, rather than being due to other features such as the recessed portions in *Hsieh*. The current amendment therefore removes this distinguishing feature over *Hsieh* (and similar prior art) in which the diameter of the droplets is determined by features on the substrate.

10/797,661

Art Unit: 2871

The applicant has amended independent claims 16 and 20 to add the limitation that "a joined portion of the liquid droplets is located at a boundary of the pixel regions". In the cited Fig. 3 of the Hsieh reference, the liquid droplets in neighboring pixel regions are separated by cell structure [150] along the pixel region boundaries, so there is no joined portion of the droplets at a boundary of the pixel regions. This language therefore distinguishes over that figure of Hsieh. However, Figs. 7A-F of Hsieh show neighboring pixel regions which have passages [630] through the cell structure, so in these embodiments there is a joined portion of the liquid droplets located at a boundary of the pixel region. Rejections based on Fig. 7 of Hsieh are therefore made below.

The applicant argues that the added limitation distinguishes over the Masazumi reference. The examiner agrees that Masazumi does not disclose a joined portion of the liquid droplets being located at a boundary of the pixel regions [there is a wall 9b' between the regions, so the neighboring liquid droplets do not touch]. The previous rejections of the method claims 16, 17, and 27 in view of Masazumi are therefore overcome.

Regarding the device claims 20, 22, and 28, the amended limitation that the device discharges droplets such that a joined portion of the liquid droplets is located at a boundary of the pixel regions does not distinguish over the previous rejections, since this is in effect a limitation regarding the intended use of the device (or regarding the LCD formed by use of the device), and the previously cited devices are clearly capable of placing droplets such that the limitation is satisfied.

10/797,661 Art Unit: 2871

To summarize the rejections, the method claims are presently rejected over *Hsieh* since the claim language does not exclude having the diameter of droplets determined to be roughly equal to the arrangement pitch of the pixel regions by features on the substrate ("thereby") and since the "joined portion" limitation does not distinguish over making the structure of Fig. 7 of *Hsieh*. The device claims are presently rejected over both *Hsieh* and *Masazumi* since they do not patentably distinguish the device itself over what is disclosed by the prior art.

#### Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
  - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 20, 22, and 28 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Masazumi et al.*, U.S. Patent No. 6,331,884 in view of *Hashizume et al.*, US 2002/0062787 and further in view of *Yamamoto et al.*, Japanese Patent Document No. 09-138410.

Masazumi discloses [see Fig. 5, for instance] a liquid crystal discharging device comprising a discharge unit for discharging liquid crystal to arrange the liquid crystal on a substrate on which a plurality of pixel regions composed of a plurality of pixels are formed, the discharge unit including a plurality of nozzles [N2, N3, N4] for discharging the liquid crystal [9a, 9a', 9a"] in a form of liquid droplets, the liquid crystal arrangement

10/797,661

Art Unit: 2871

device discharges the liquid droplets from the nozzles such that each of the liquid droplets has a certain amount and the diameter of the liquid droplets after impact is roughly equal to the arrangement pitch of the plurality of pixel regions [see Fig. 1B; note that since the resin 9b constitutes a non-display area, it will have a small size relative to the pixel display area, so the diameter will by "roughly equal" to arrangement pitch, within the scope of how the examiner understands that relative term; also note that the resin does not act to define the placement of the liquid crystal as the recessed portions in *Hsieh* do], to coat each of the plurality of pixel regions with the liquid droplets.

Masazumi does not disclose a weight measurement device which measures a weight of a single liquid droplet for obtaining a diameter and determining an arrangement pitch of the liquid droplets to be arranged in line on the substrate based on the diameter of the liquid droplets after impact of the liquid droplets on the substrate, which was measured in advance. Masazumi appears to be silent on how the amount of the liquid crystal dropped is determined.

Hashizumi discloses [see paragraphs 0103-0104, for instance] an analogous discharge unit with a weight measurement device [54] which measures a weight of the single liquid droplet, enabling the discharge unit to discharge the liquid droplets from the nozzles such that each of the liquid droplets has said weight. It would have been obvious to one of ordinary skill in the art at the time of the invention to have such a weight measurement device, motivated by the teaching of *Hashizumi* that this allows the drop sizes to be constant, despite environmental (or other) changes during the processing.

10/797,661 Art Unit: 2871

Yamamoto teaches [see Fig. 7] that when using an ink-jet/nozzle technique, the diameter of the liquid droplets after impact of the liquid droplets on the substrate should be considered, since having droplets too far apart [as in Fig. 7b] leads to separated droplets on the substrate and an uneven coverage of the substrate, for instance. It would therefore have been obvious to one of ordinary skill in the art at the time of the invention to use a method in which an arrangement pitch of the liquid droplets is determined based on a diameter of the liquid droplets after impact on the substrate, which would have to be measured in advance (or the teaching could not be applied).

The additional limitation of claim 20 is that a joined portion of the liquid droplets is located at a boundary of the pixel regions. This is in effect a limitation on the intended use of the device; the device disclosed by the prior art is capable of performing this function, so the limitation does not distinguish the claimed device over the prior art.

In order to function, this device necessarily has a controller as recited in claim 20 and a drive system as recited in claim 22. Claims 20 and 22 are therefore unpatentable.

Masazumi does not disclose that the arrangement pitch is obtained by selecting a subset of the nozzles having a pitch therebetween equal to the arrangement pitch, among the plural nozzles. The examiner takes official notice that ink-jet heads having a plurality of nozzles, with only a subset of nozzles being activated at a given instant, are well-known in the art [this assertion was not traversed by the applicant, so it is now considered admitted prior art, see MPEP 2144.03]. It would have been obvious to one of ordinary skill in the art at the time of the invention to do so, motivated by the desire to

10/797,661

Art Unit: 2871

have the flexibility to use an available nozzle head and selecting a subset of its nozzles having the desired arrangement pitch, rather than having to obtain a specially designed nozzle head having its nozzle arrangement matching the pixel arrangement (which can vary for different devices which would beneficially be manufactured using the same equipment). The controller would thereby control the interval by selecting the nozzles having a pitch therebetween equal to the arrangement pitch, among the plural nozzles. Claim 28 is therefore unpatentable.

5. Claims 16, 17, 20, and 22 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Hsieh et al.*, U.S. Patent No. 6,867,840 in view of *Hashizume et al.*, US 2002/0062787 and further in view of *Yamamoto et al.*, Japanese Patent Document No. 09-138410.

Considering claim 20, *Hsieh* discloses [see Figs. 3E and 7, for instance] a liquid crystal discharging device comprising a discharge unit for discharging liquid crystal [170] to arrange the liquid crystal on a substrate [100] on which a plurality of pixel regions composed of a plurality of pixels are formed, the discharge unit comprising a plurality of nozzles which discharge liquid crystal in a form of liquid droplets, with each of the plurality of pixel regions being coated with the liquid droplets. As shown in Fig. 7, due to the passages [630] through the walls around the pixel regions, there is a joined portion of the liquid droplets which is located at a boundary of the pixel regions.

Hsieh does not disclose a weight measurement device which measures a weight of the single liquid droplet, and the discharge unit discharging the liquid droplets from the nozzles such that each of the liquid droplets has said weight and thereby the

10/797,661

Art Unit: 2871

diameter of the liquid droplets after impact is roughly equal to the arrangement pitch of the plurality of pixel regions, and each of the plurality of pixel regions is coated with the liquid droplets.

Hashizumi discloses [see paragraphs 0103-0104, for instance] an analogous discharge unit with a weight measurement device [54] which measures a weight of the single liquid droplet, enabling the discharge unit to discharge the liquid droplets from the nozzles such that each of the liquid droplets has said weight. It would have been obvious to one of ordinary skill in the art at the time of the invention to have such a weight measurement device, motivated by the teaching of Hashizumi that this allows the drop sizes to be constant, despite environmental (or other) changes during the processing.

Hsieh also does not disclose that there is a controller that controls an interval between the liquid crystal discharged from the nozzles based on a diameter of the liquid droplets after impact of the liquid droplets on the substrate, which was measured in advance. This has two parts: the controller, and what is considered when determining the arrangement pitch of the liquid droplets.

Yamamoto discloses [see Fig. 7] having the nozzles move along the substrate at a certain rate; this inherently requires a controller which controls the rate and thus the interval between the droplets. Yamamoto also teaches [see Fig. 7] that when using an ink-jet/nozzle technique, the diameter of the liquid droplets after impact of the liquid droplets on the substrate should be considered, since having droplets too far apart [as in Fig. 7b] leads to separated droplets on the substrate and an uneven coverage of the

10/797,661

Art Unit: 2871

substrate, for instance. It would therefore have been obvious to one of ordinary skill in the art at the time of the invention to use a method in which an interval between the liquid droplets is determined based on a diameter of the liquid droplets after impact on the substrate, which would have to be measured in advance (or the teaching could not be applied).

Claim 20 is therefore unpatentable.

Considering claim 22, *Hsieh* appears to disclose aligning each impact location of the liquid droplets with each location of the pixel regions (if not, this would have been an obvious matter of optimization). However, *Hsieh* does not disclose a drive system for moving the nozzle and the substrate relative to each other (*Hsieh* shows only a cross-sectional slice of its device, and is silent on how the entire substrate is covered). *Yamamoto* discloses [see Figs. 6 and 7, for instance] an inkjet device with a plurality of nozzles [Fig. 6] as shown in *Hsieh*, which covers the entire substrate by being moved by a drive system [inherent in Fig. 7]. It would have been obvious to one of ordinary skill in the art at the time of the invention to use such a drive system in the device of *Hsieh*, motivated by the desire to use a single small set of nozzles to efficiently and flexibly cover substrates of varying sizes. Claim 22 is therefore unpatentable.

The use of the arrangement device discussed above results in the method recited in claim 16, determining an arranged pitch of the liquid droplets to be arranged in line [left to right in Fig. 7 of *Yamamoto*], with the interval determined as recited, measuring the weight of the droplet for obtaining the desired diameter, and discharging

10/797,661

Art Unit: 2871

the liquid droplets from nozzles while maintaining the arrangement pitch, so claim 16 is also unpatentable.

The arrangement pitch, as seen from *Yamamoto*, is a result-effective variable whose optimization would have been obvious to one of ordinary skill in the art at the time of the invention. Furthermore, *Yamamoto* teaches having it be roughly equal to the diameter of the liquid droplets after impact (to obtain even coverage over the substrate). Claim 17 is therefore unpatentable.

6. Claims 27 and 28 are rejected under 35 U.S.C. 103(a) as being unpatentable over *Hsieh et al.*, U.S. Patent No. 6,867,840 in view of *Hashizume et al.*, US 2002/0062787 and *Yamamoto et al.*, Japanese Patent Document No. 09-138410 as applied above, and further in view of *Yamamoto et al.*, US 2004/0201818.

Yamamoto '818 discloses [see Fig. 5] a ink-jet nozzle system in which the nozzles are controllable (by a controller). It would have been obvious to one of ordinary skill in the art at the time of the invention to use such an ink-jet system, motivated by the desirability of being able to control the nozzles to turn on and off.

In the device and method discussed above, liquid is dropped from all the nozzles shown in *Hsieh* and *Yamamoto*; alternatively stated, the arrangement pitch is obtained by selecting all the nozzles, and the nozzles have a pitch equal to the arrangement pitch, among the plural nozzles. Similarly, the controller controls the interval in part by selecting all the nozzles, as well as in part by selecting the drive speed. The above device and method do not disclose that the arrangement pitch is obtained by selecting a subset of the nozzles having a pitch therebetween equal to the arrangement pitch.

10/797,661

Art Unit: 2871

among the plural nozzles. The examiner takes official notice that ink-jet heads having a plurality of nozzles, with only a subset of nozzles being activated at a given instant, are well-known in the art [this assertion was not traversed by the applicant, so it is now considered admitted prior art, see MPEP 2144.03]. It would have been obvious to one of ordinary skill in the art at the time of the invention to do so, motivated by the desire to have the flexibility to use an available nozzle head and selecting a subset of its nozzles having the desired arrangement pitch, rather than having to obtain a specially designed nozzle head having its nozzle arrangement matching the pixel arrangement (which can vary for different devices which would beneficially be manufactured using the same equipment). The controller would thereby control the interval by selecting the nozzles having a pitch therebetween equal to the arrangement pitch, among the plural nozzles. Claims 27 and 28 are therefore unpatentable.

#### Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andrew Schechter whose telephone number is (571) 272-2302. The examiner can normally be reached on Monday - Friday, 9:00 - 5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

10/797,661 Art Unit: 2871

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Andrew Schechter
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24 December 2007